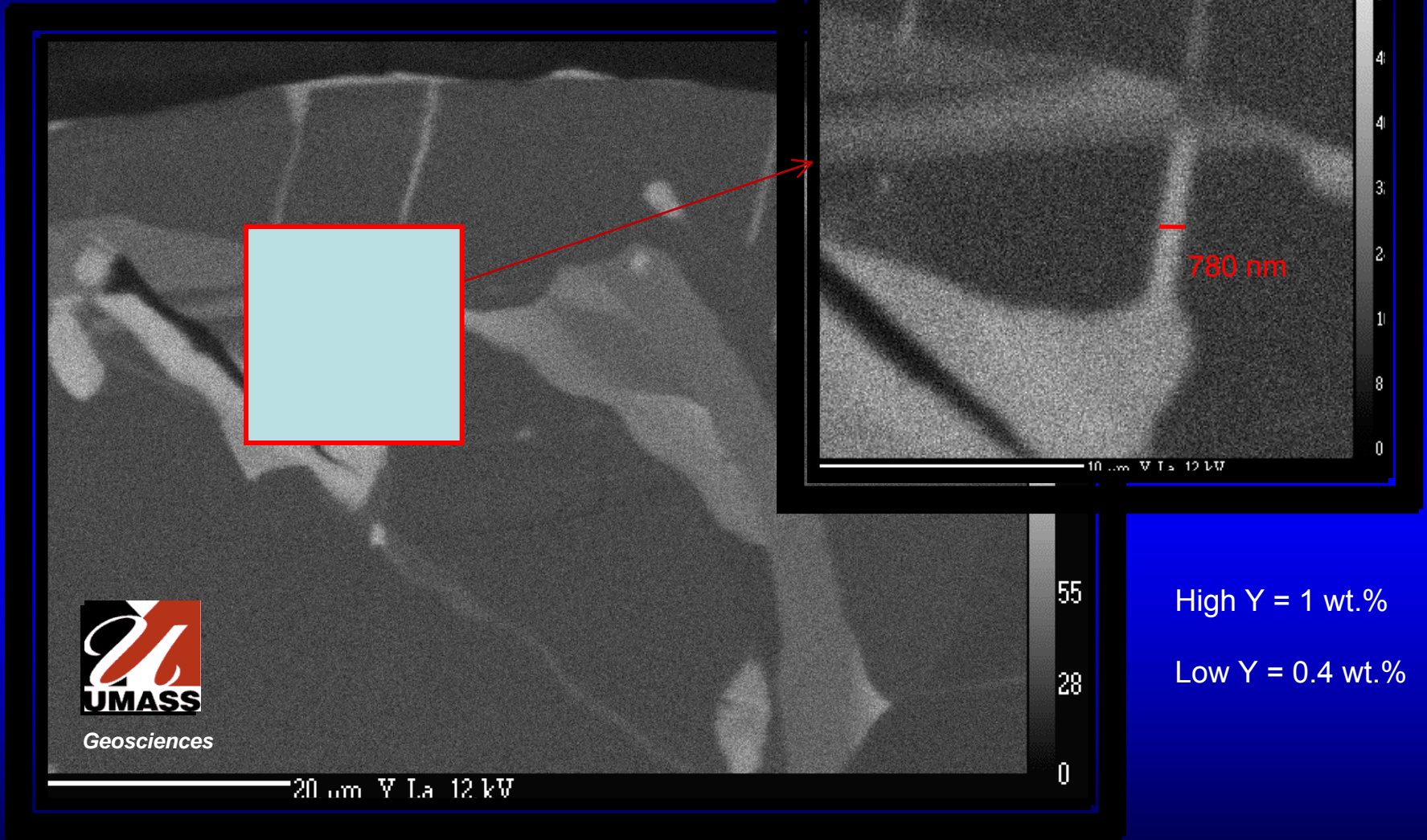


Practical Considerations in Trace Element Analysis by EPMA



High Y = 1 wt. %

Low Y = 0.4 wt. %

100 nA, 12 kV, 50 ms/pixel

Considerations:

Precision = counts

Accuracy = accurate net intensity

background measurement

peak measurement

interferences on peak and background

- elements in the phase of interest
- lines fluoresced from adjacent phases or compositional domains

Solutions:

Precision = current and count time – *Not the problem*

Improved sensitivity (lower MDL), more efficient spectrometers,
higher, more stable currents

Accuracy =

Sample preparation and coating are critical

Map! Know the layout of the environment

High resolution WDS scanning

evaluation must be commensurate with the sensitivity of
the analysis!

Minimize drift (contamination, dynamic charge effects, source
stability, etc.) and beam damage (high current density)

Background measurement – must account for background shape

Spectrometer efficiency

Natural Bremsstrahlung

Watch for 'holes'

Peak measurement - watch for interferences – peak tails

Accurate interference corrections

Be wary of fluorescence at a distance

Induced by characteristic radiation

Induced by continuum – especially from high Z phases

Zr in rutile (thermometry)

Relatively low spatial resolution analysis

20 kV, 200nA, 5 spectrometer integration, 600 sec.
acquisitions *Integrating PET, two LPETs, and 2 VLPETs*

= Single point detection limit of 14ppm (3σ) for Zr

= Grain average yields an overall detection limit of 3 ppm
(3σ) for 15 points, and 4 ppm (3σ) for 10 points

Solutions:

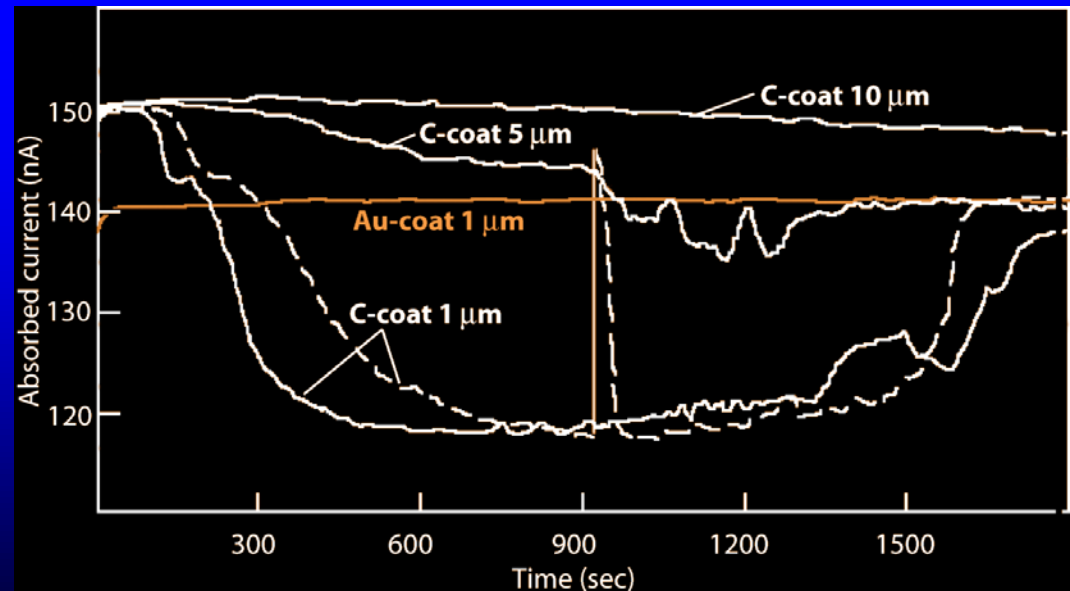
Accuracy =
Sample preparation and coating are critical

A few brief thoughts on sample preparation –

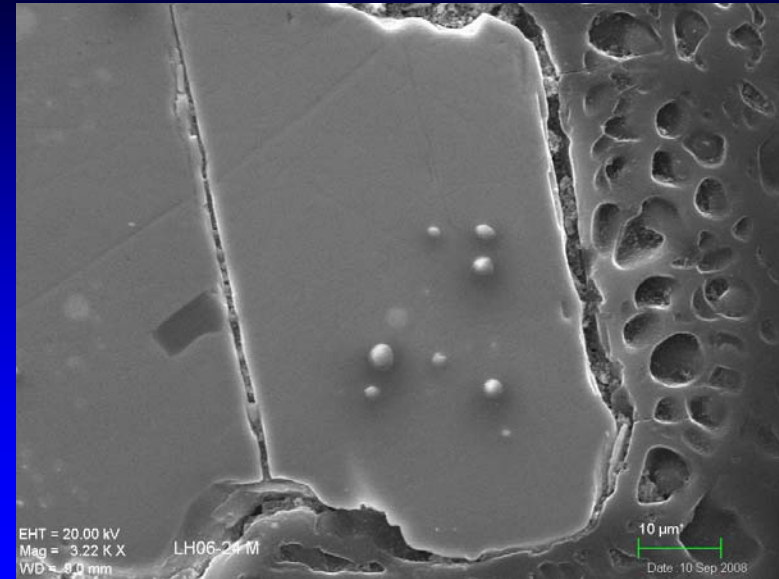
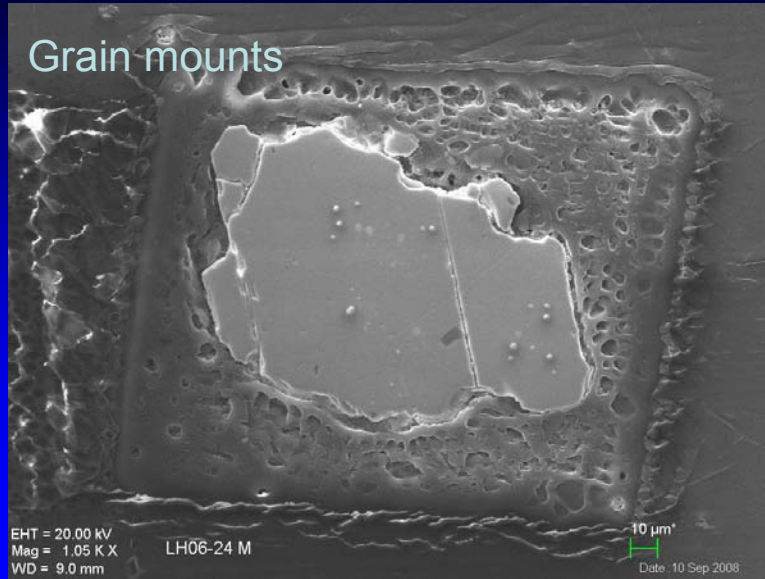
Trace element analysis (precision = counts) *very high current (voltage?)*
very long count times

Must consider the sample
High current density
Beam damage
Internal charge effects

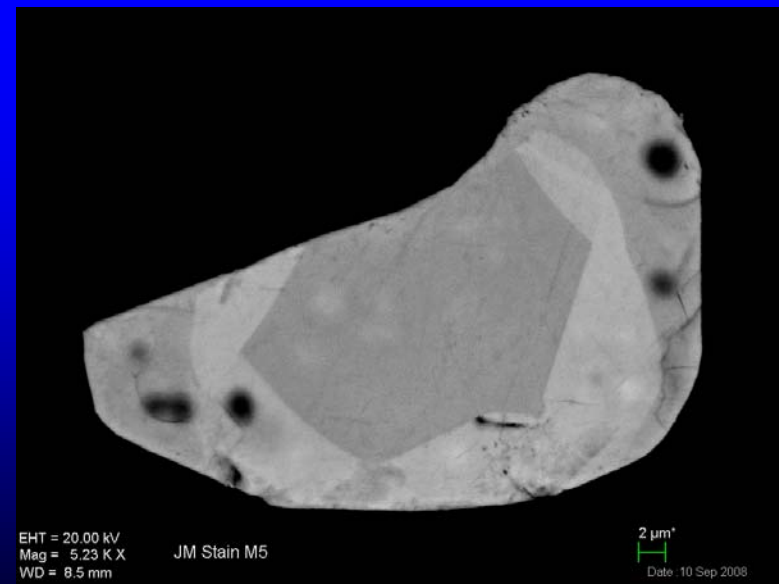
Boundaries and edge preservation



Grain mounts



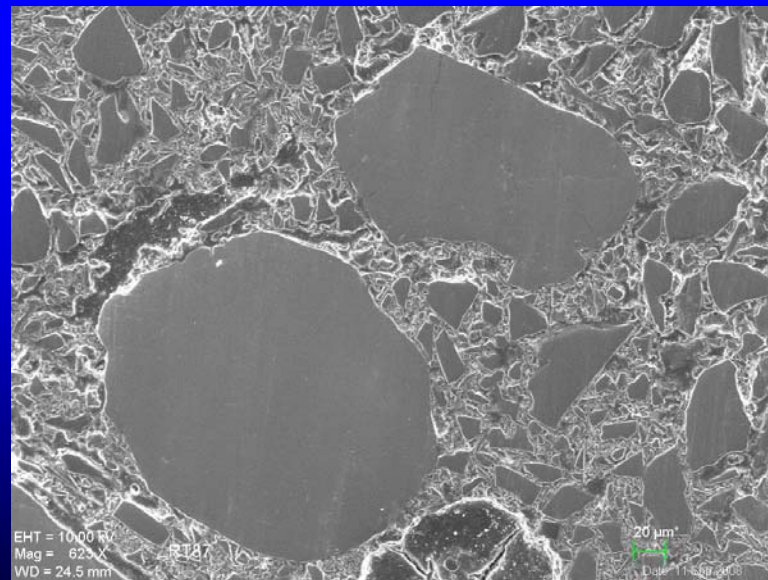
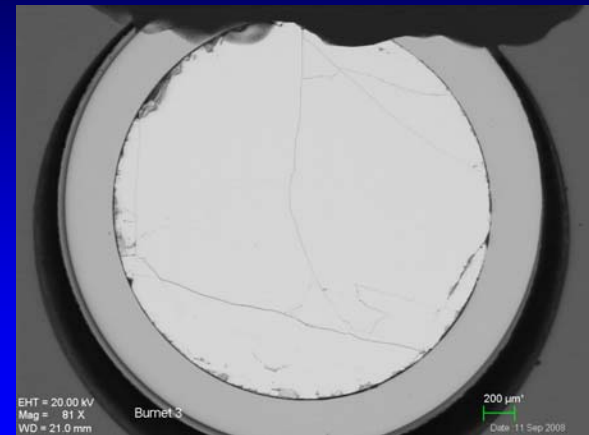
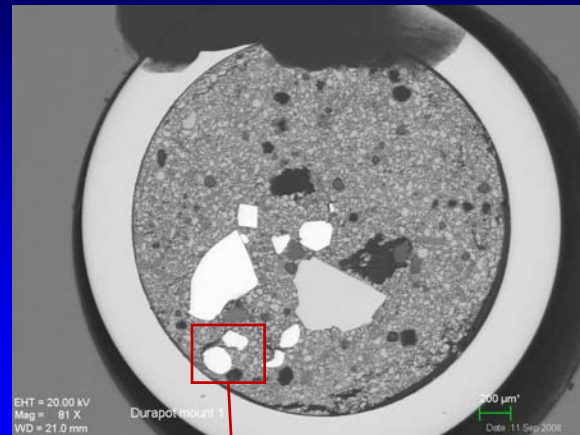
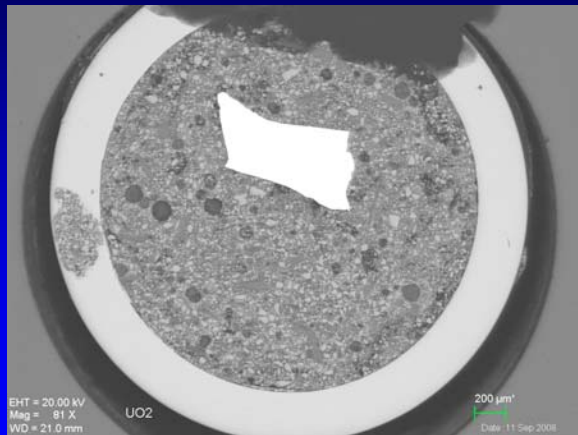
Thin sections – *in situ* analysis!



Grain mounts

Potting - Casting ceramics

Micro-drill, press fit, and Ni-epoxy

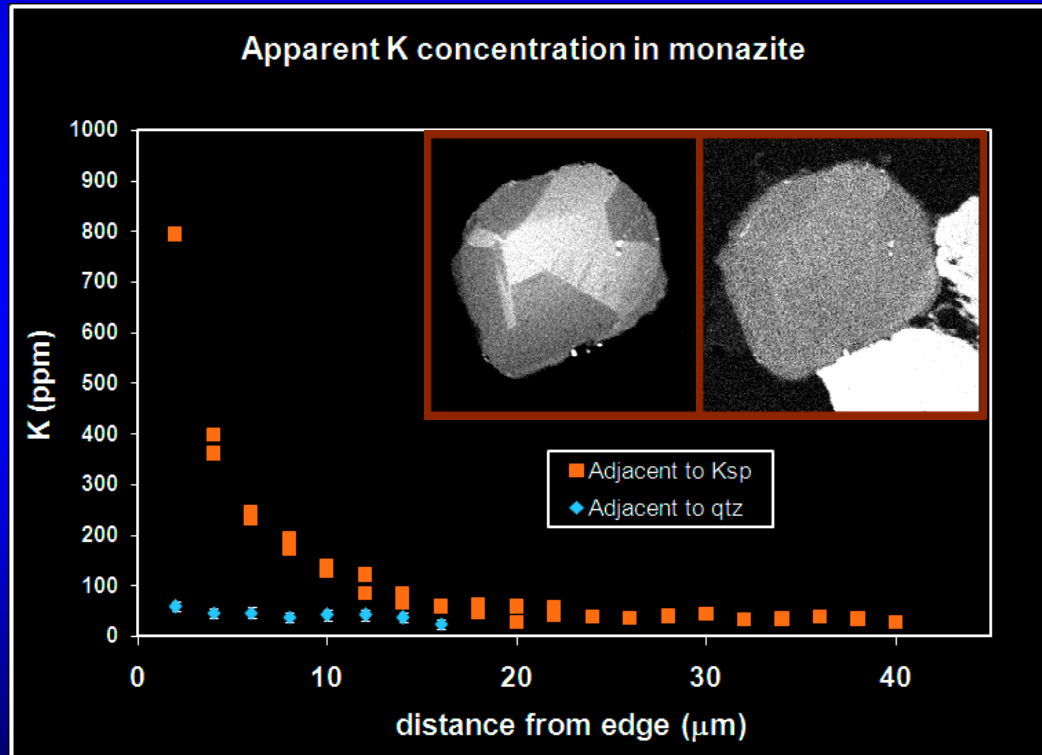


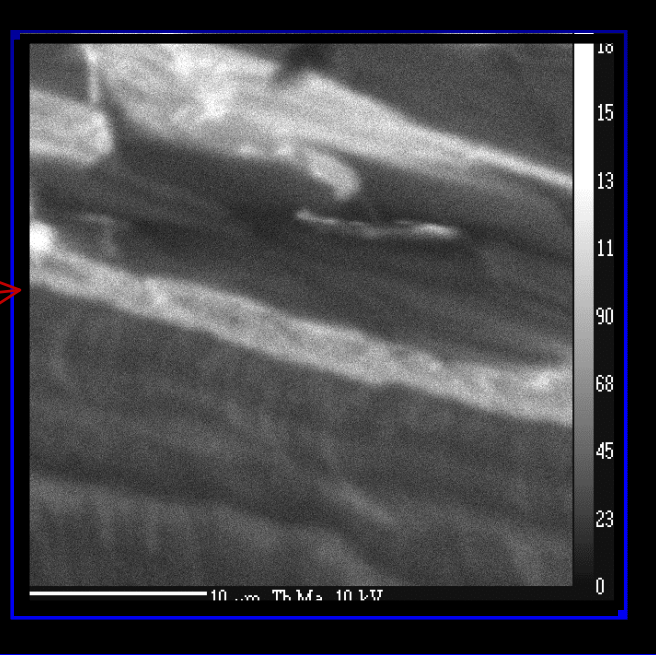
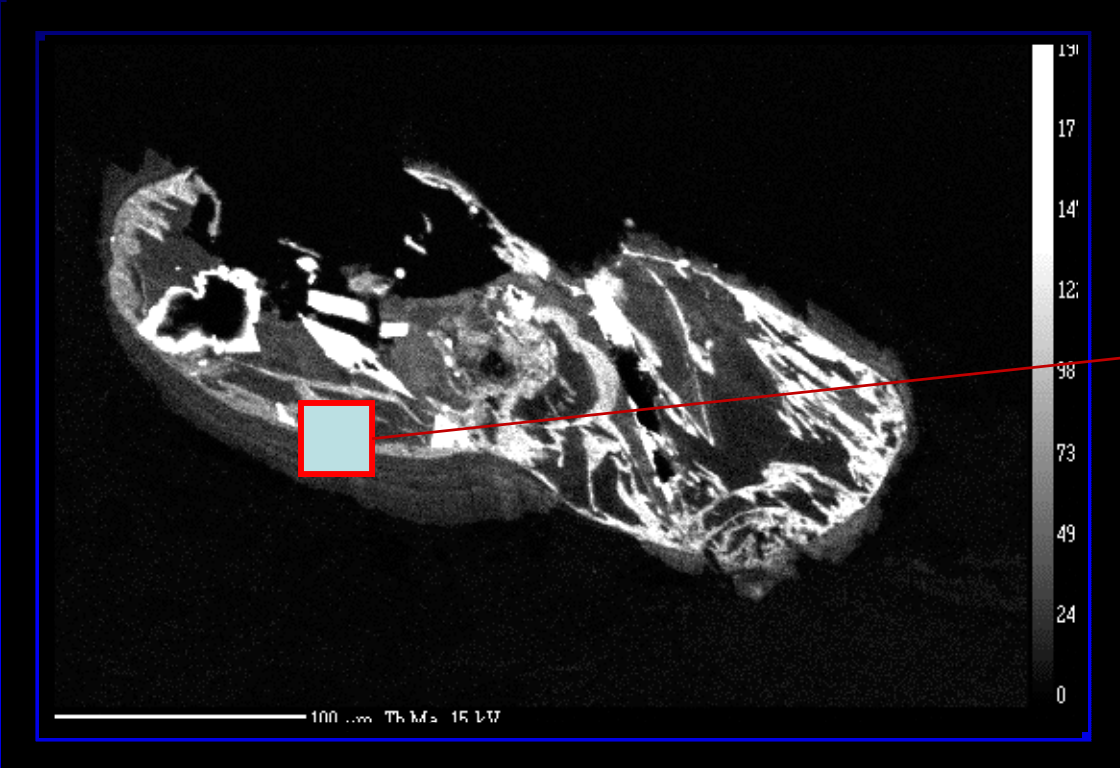
Solutions:

Accuracy =

Map!

Know the layout of the environment



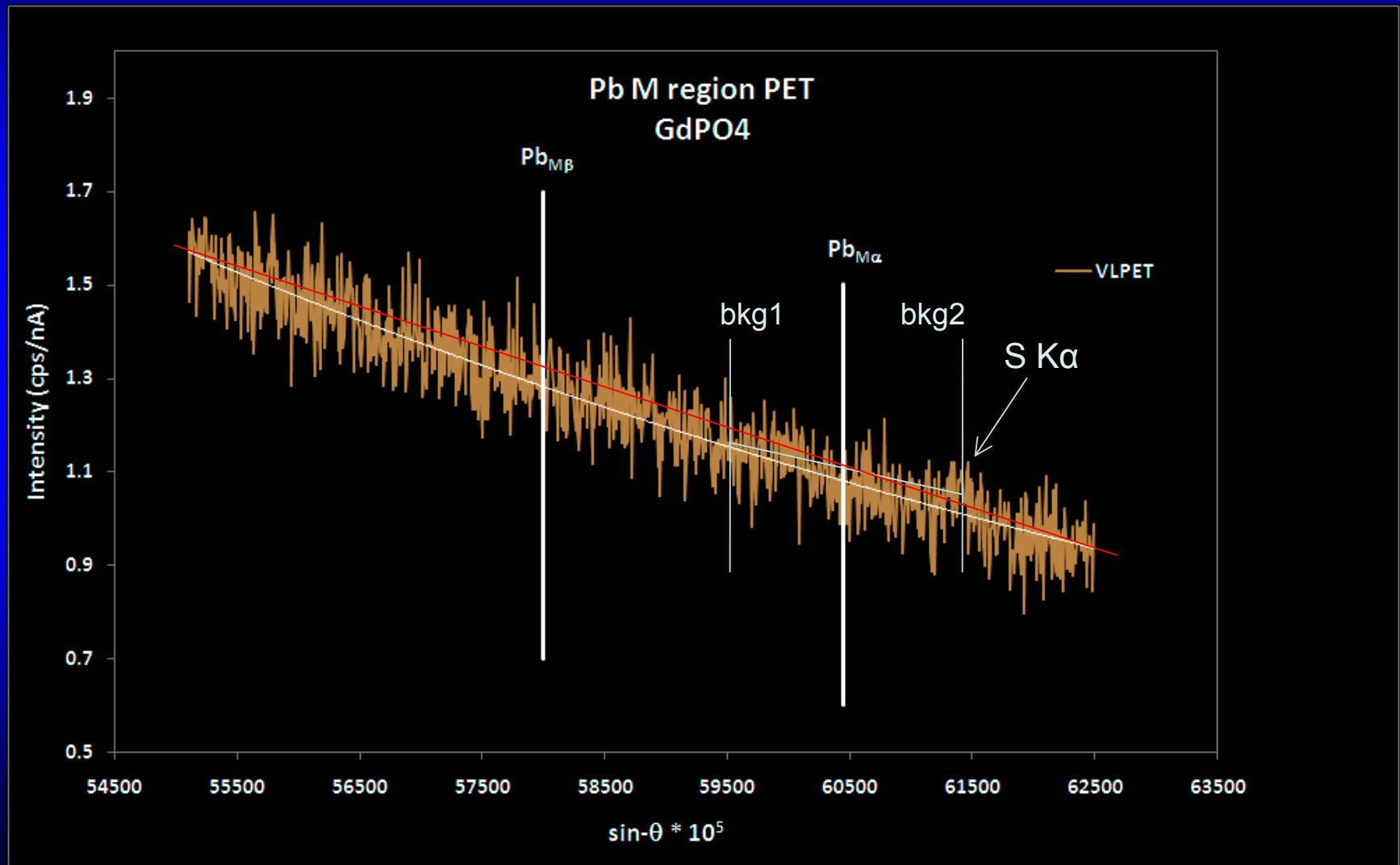


Solutions:

Accuracy =

High resolution WDS scanning

evaluation must be commensurate with the sensitivity of the analysis!



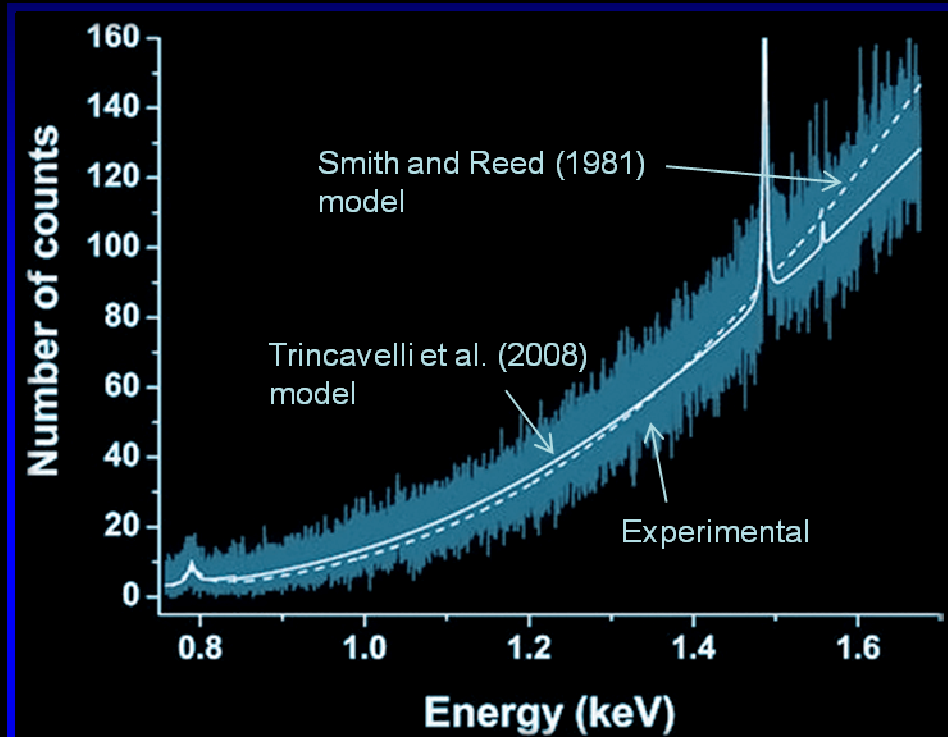
Solutions:

Accuracy =

Minimize drift (contamination, dynamic charge effects, source stability, etc.) and beam damage (high current density)

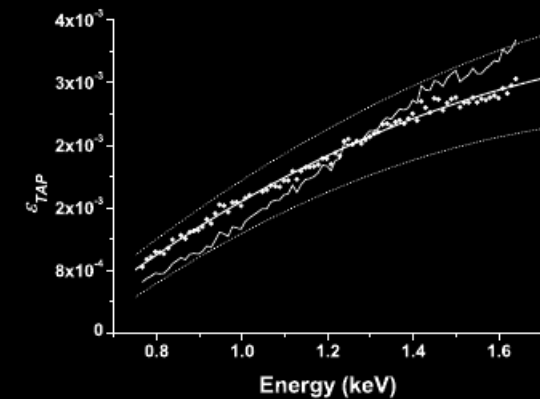
Peak measurement - watch for interferences – peak tails
Accurate interference corrections

Background measurement – must account for background shape
Spectrometer efficiency
Natural Bremsstrahlung
Watch for 'holes'

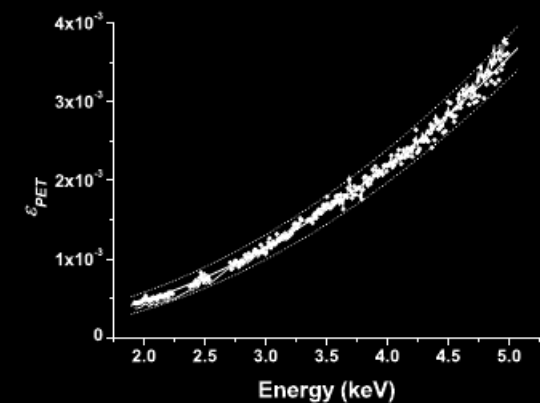


Spectrometer efficiency: Hematite spectrum (TAP) Trincavelli et al., 2008

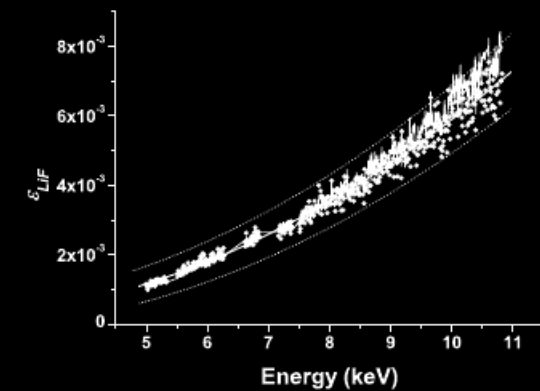
$$\varepsilon_{\text{WDS}}(E) = \frac{N_{\text{WDS}}^{\text{grouped}}(E)(i\Delta t)_{\text{EDS}}}{N_{\text{EDS}}(E)(i\Delta t)_{\text{WDS}}} \frac{\Delta\Omega_{\text{EDS}}}{4\pi} \varepsilon'_{\text{EDS}}(E)$$



(a)

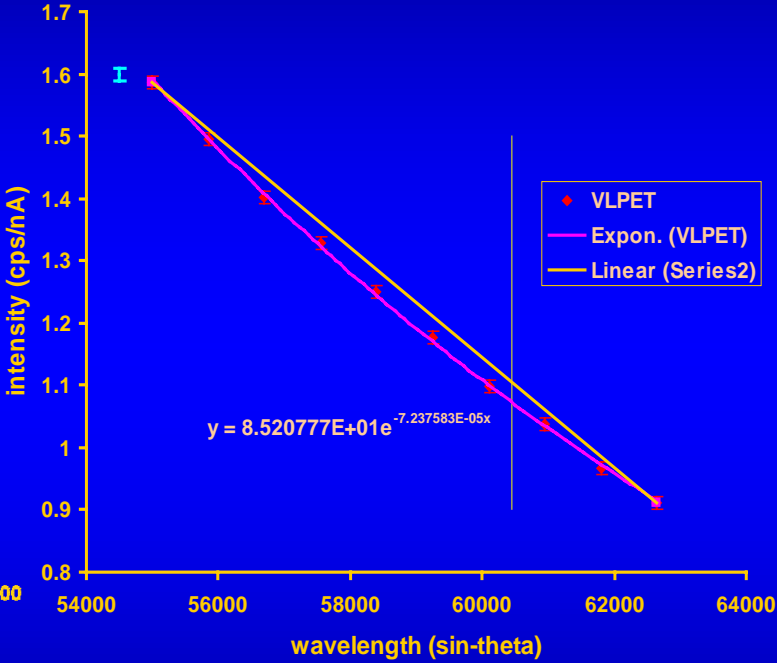
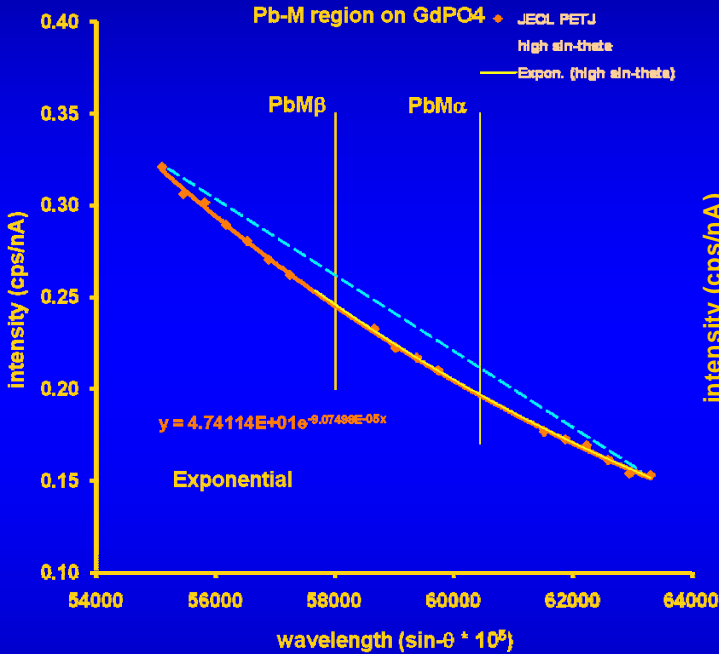


(b)

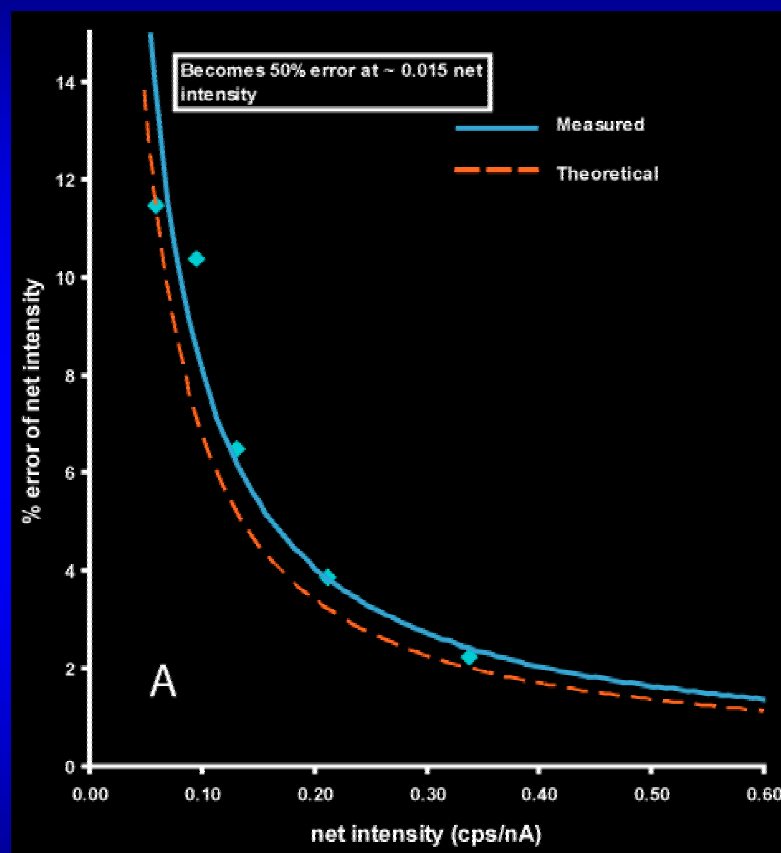


(c)

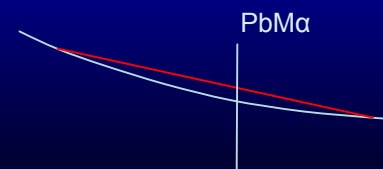
sp3

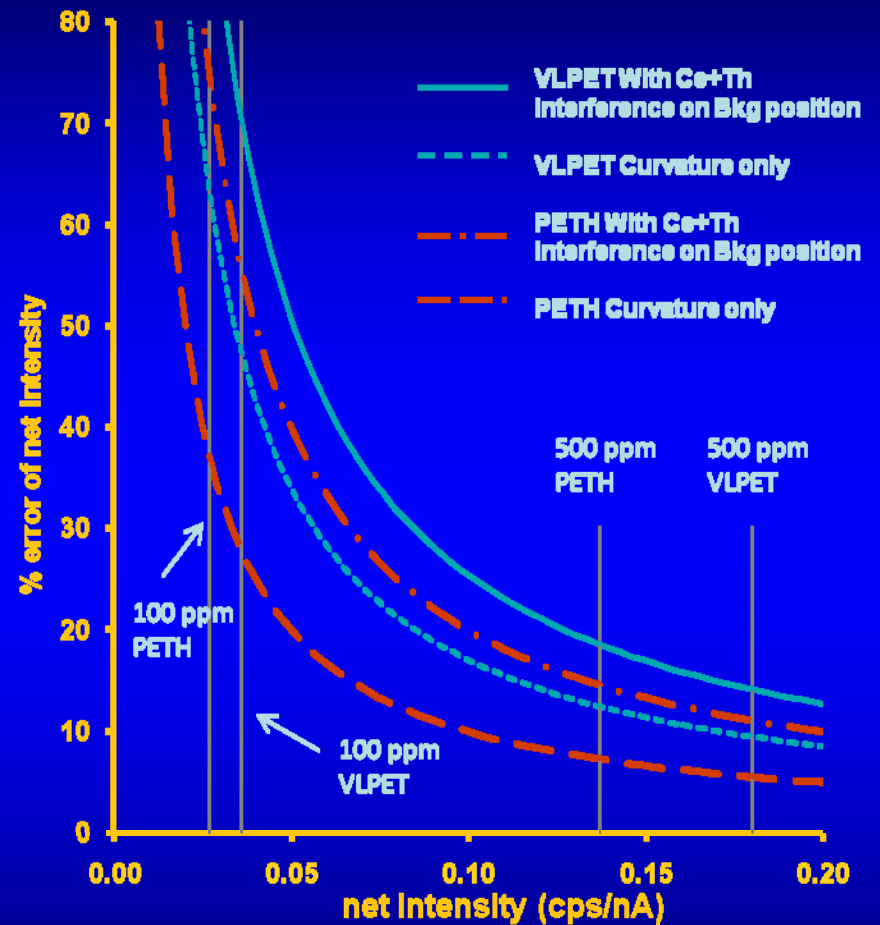
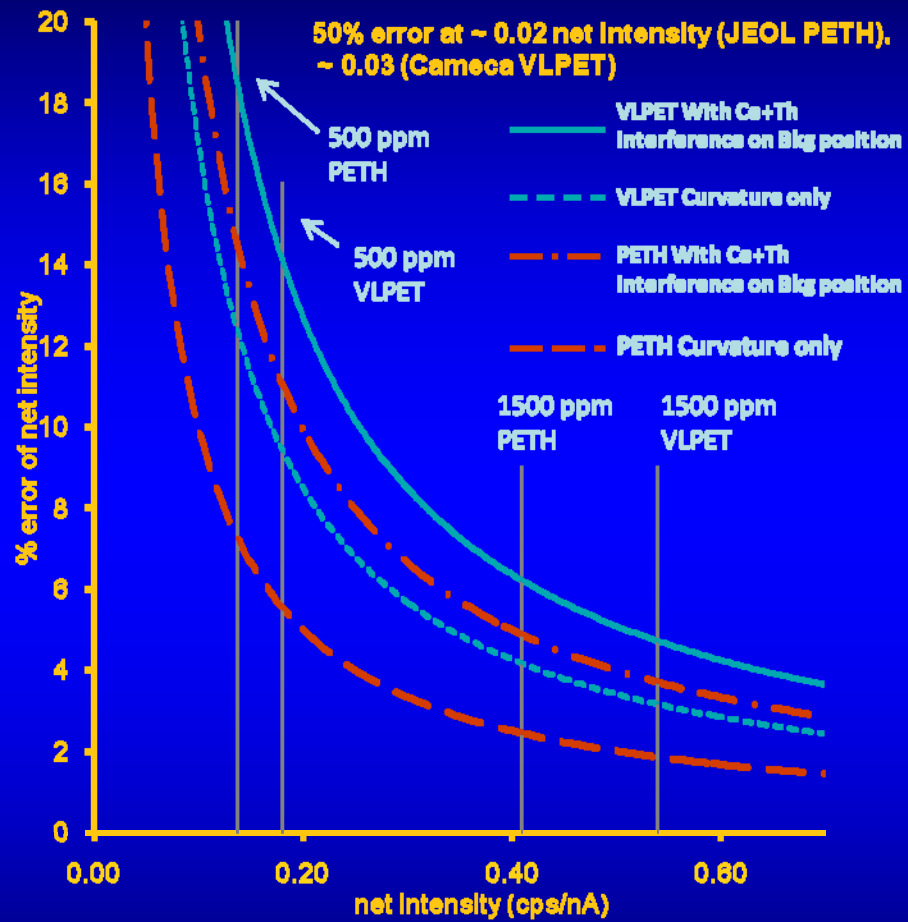


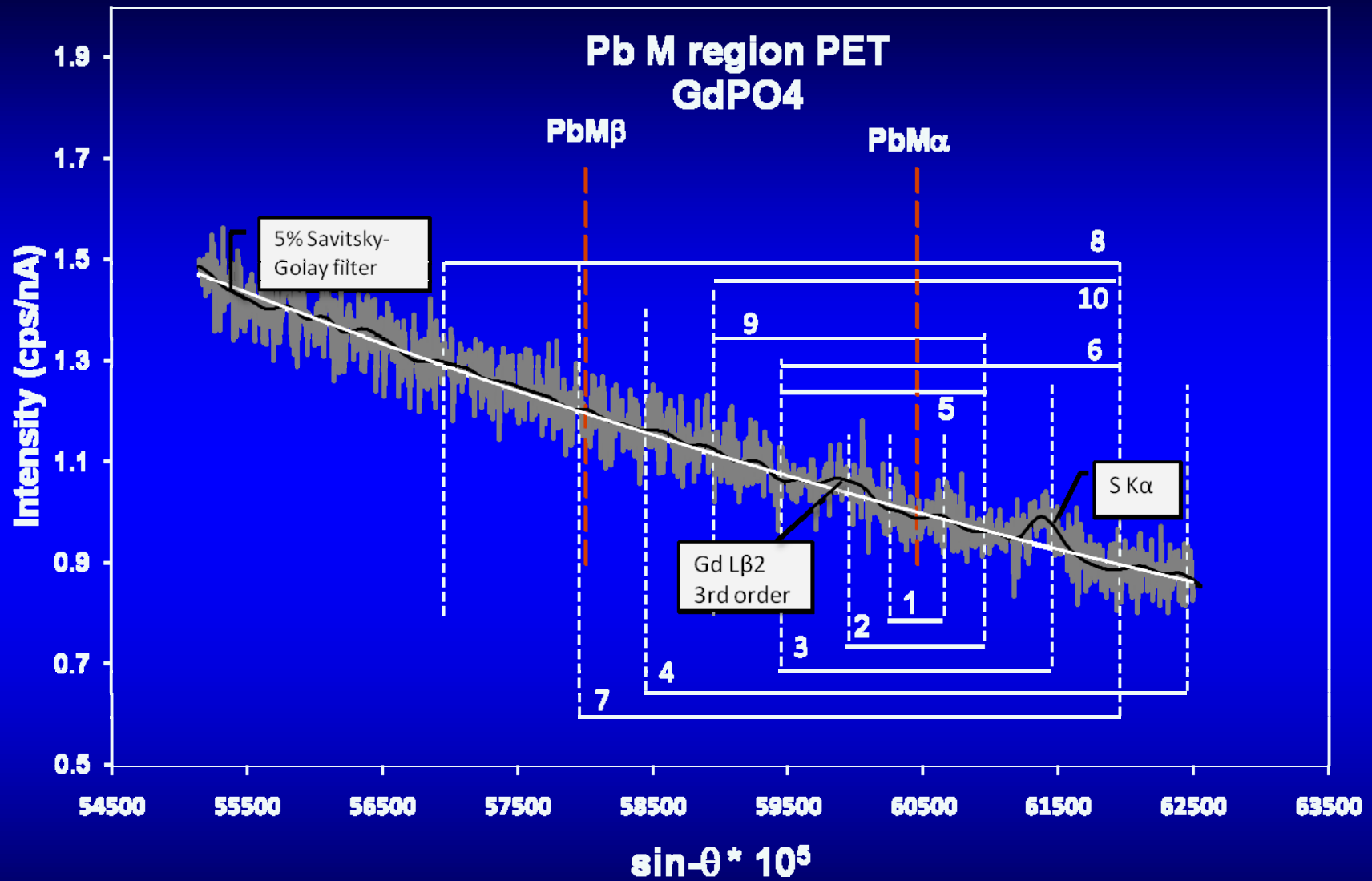
Errors - Background shape

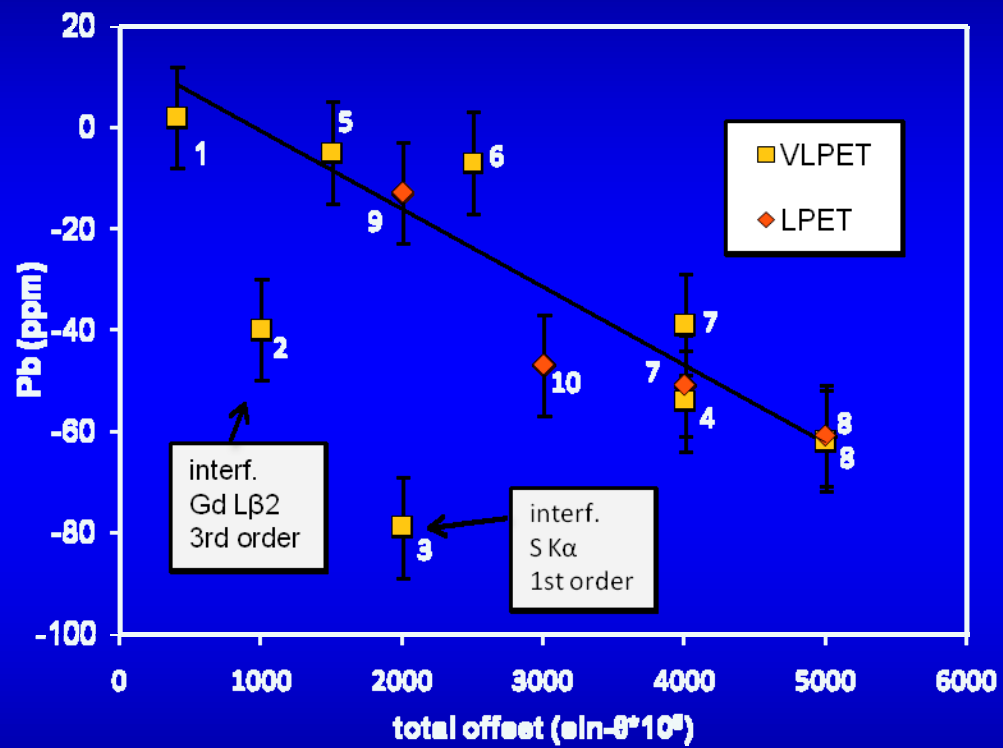


Error due to improper background model for PbMa as peak intensity is lowered (lower concentration)

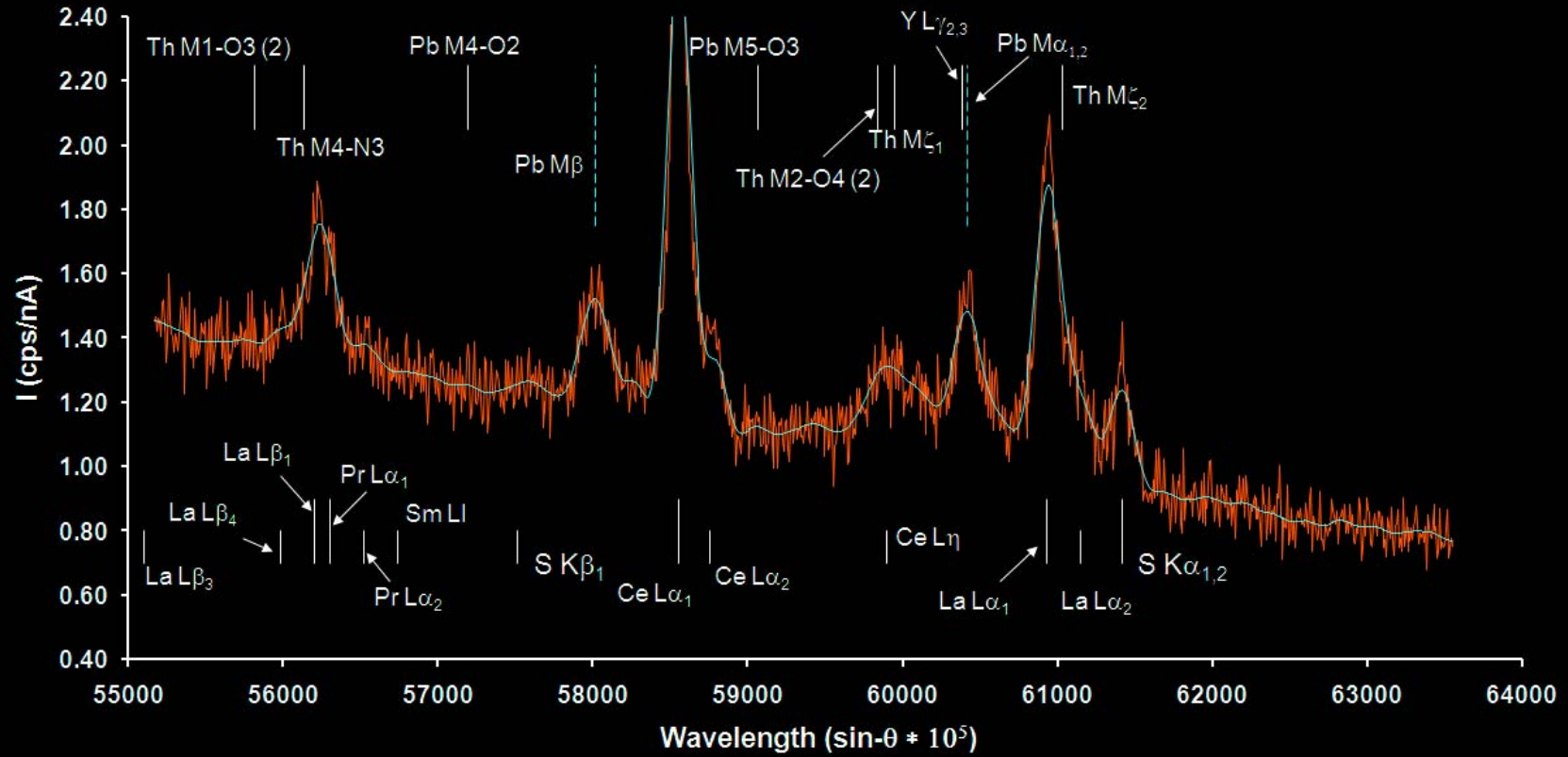




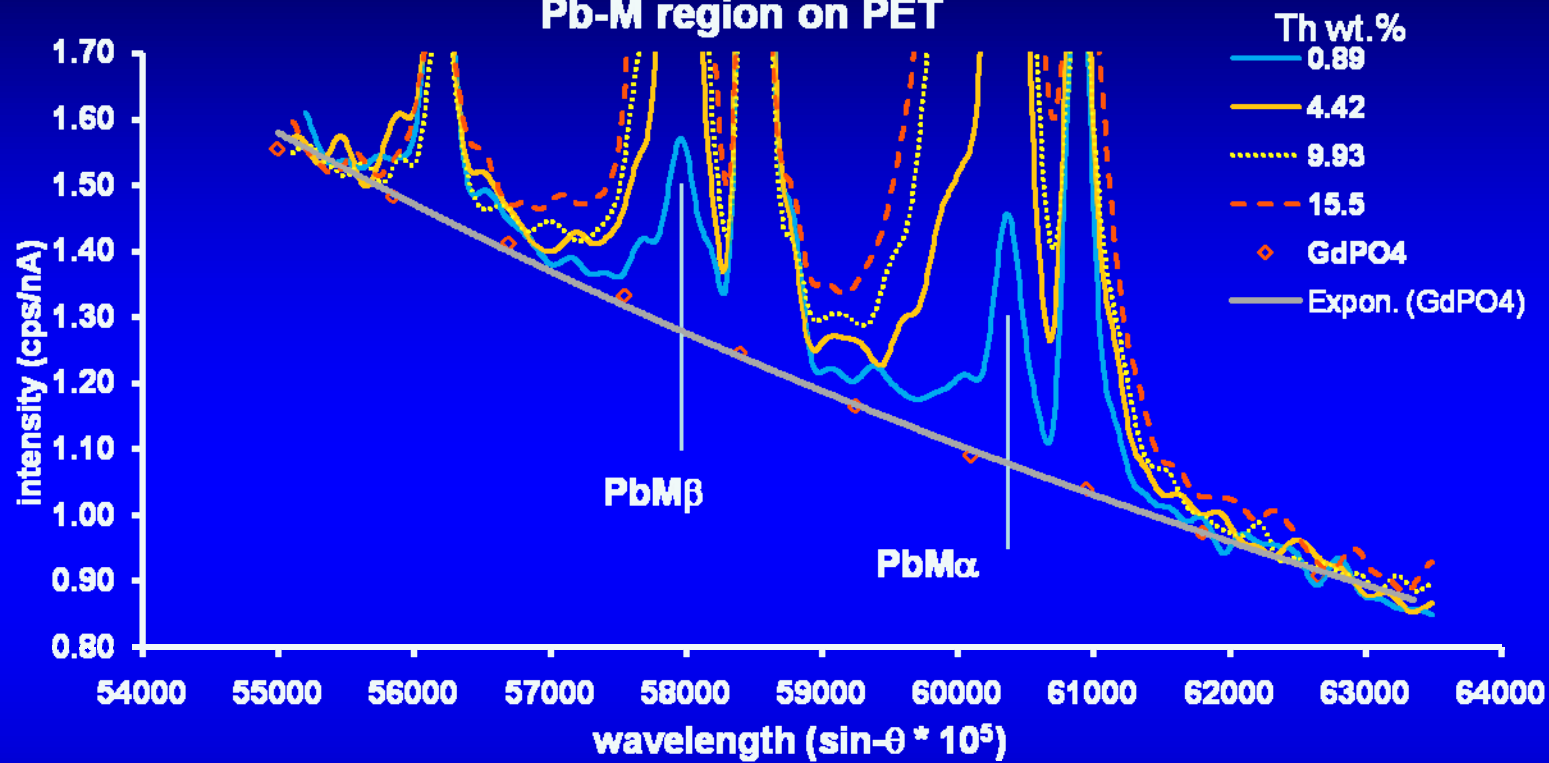




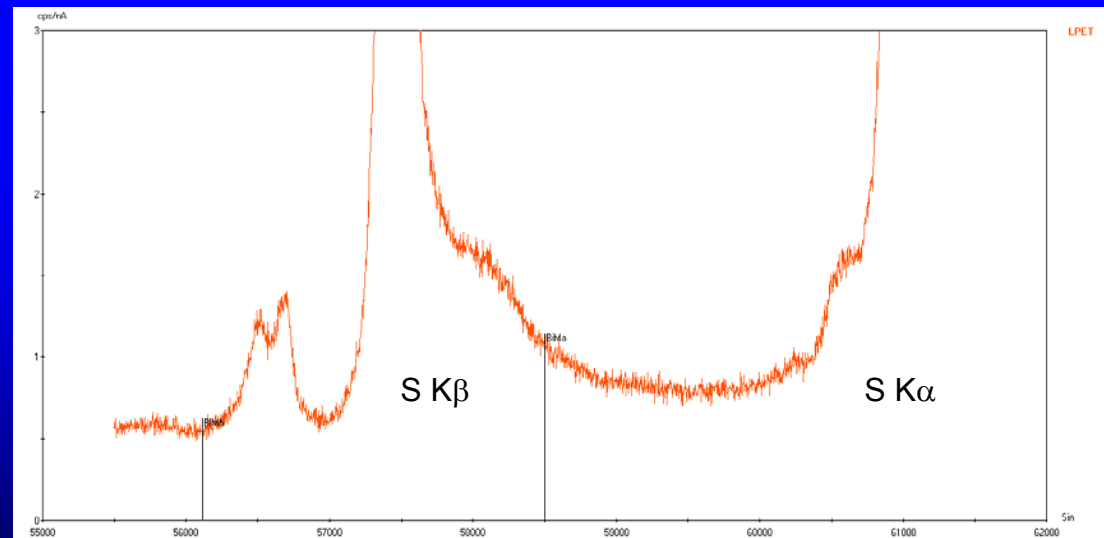
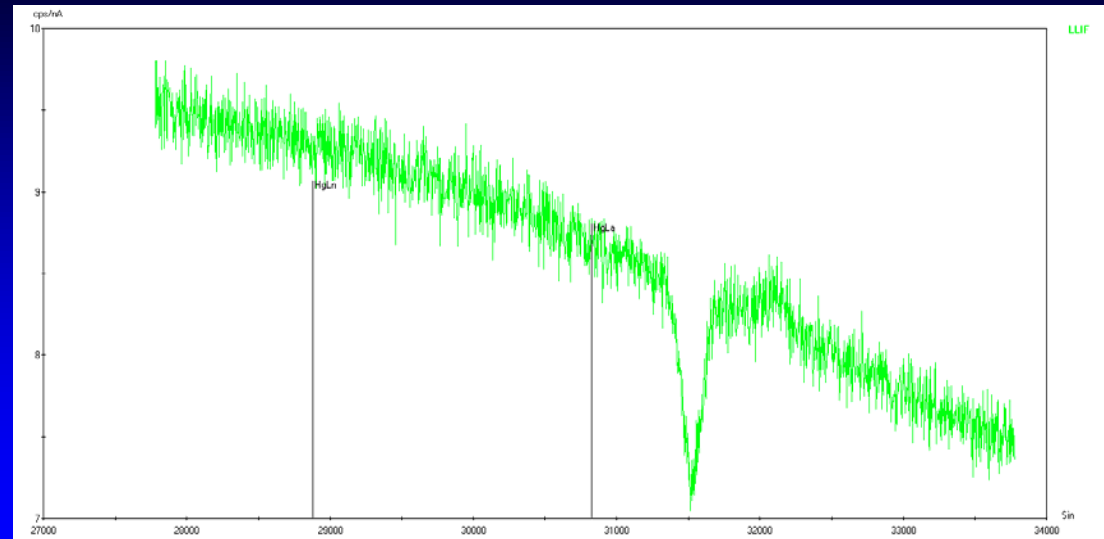
Monazite GSC 8153 Pb region (PET)



Pb-M region on PET



LLIF



Bi measurement in sulfides and satellites of sulfur diagram lines,

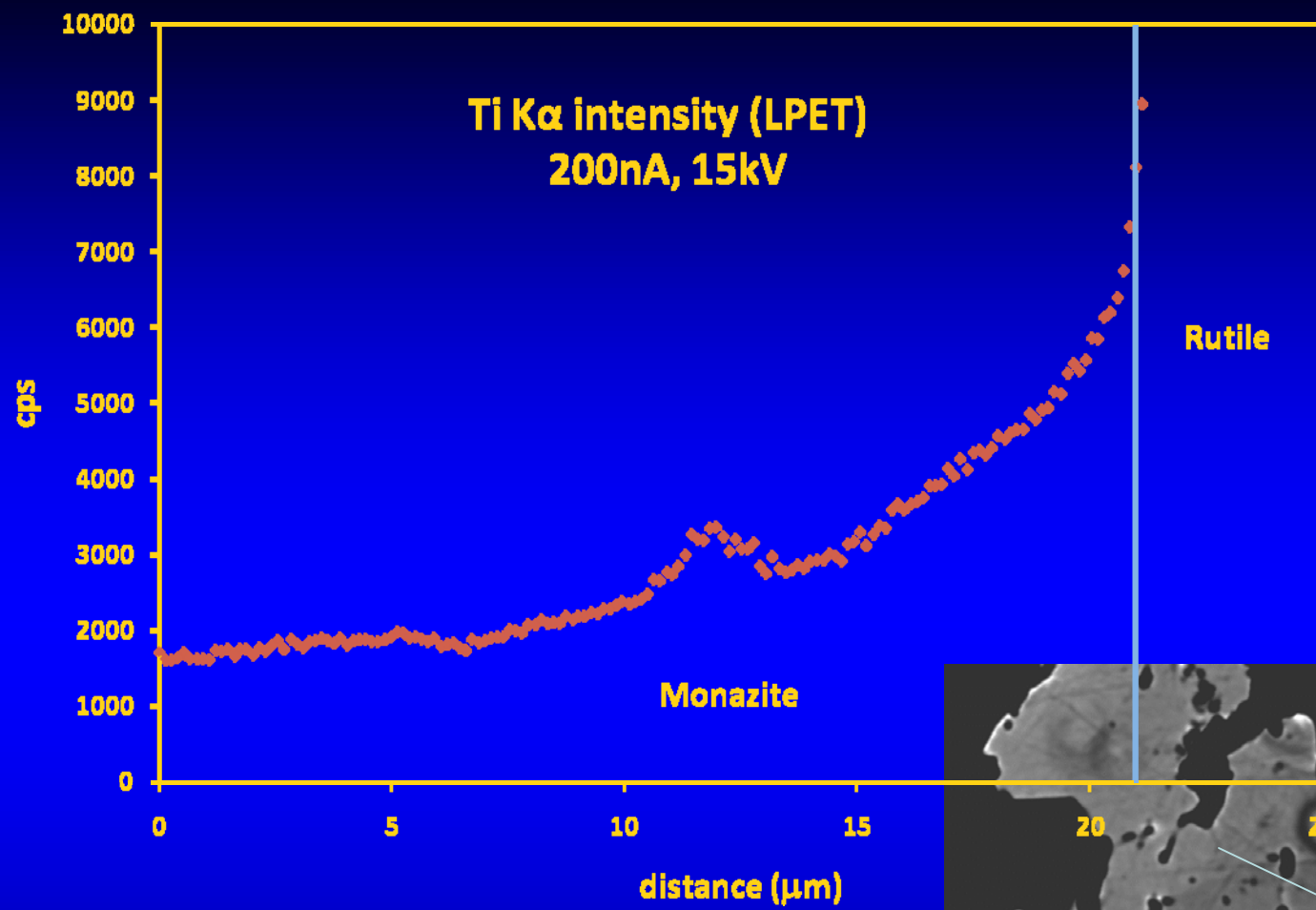
Solutions:

Accuracy =

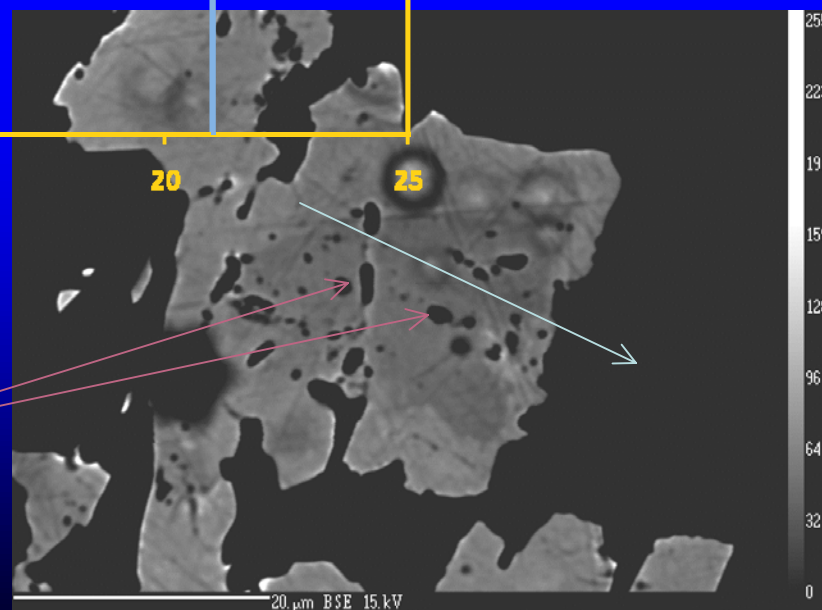
Be wary of **fluorescence** at a distance

Induced by characteristic radiation

Induced by continuum – especially from high Z phases



Rutile
inclusions

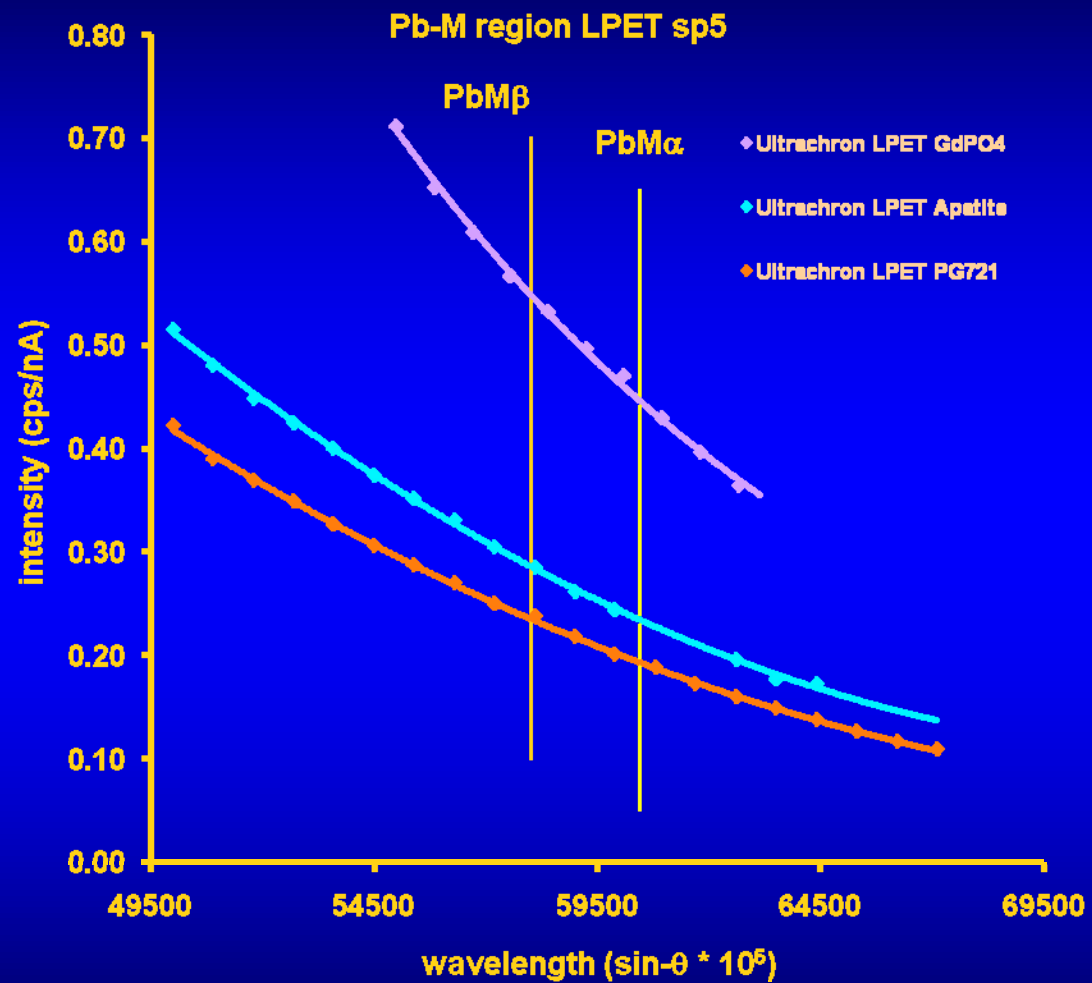


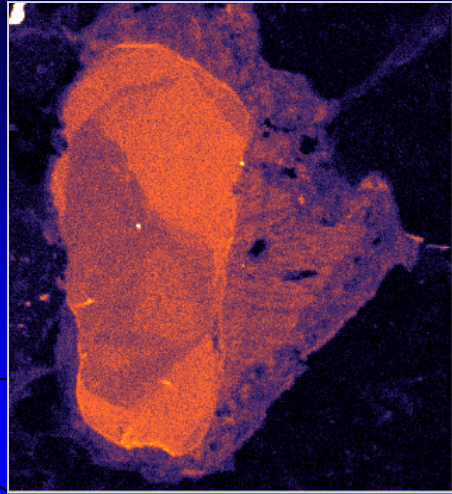
Dependable secondary standards for
trace concentrations?

Ion probe?
LA-ICP-MS?

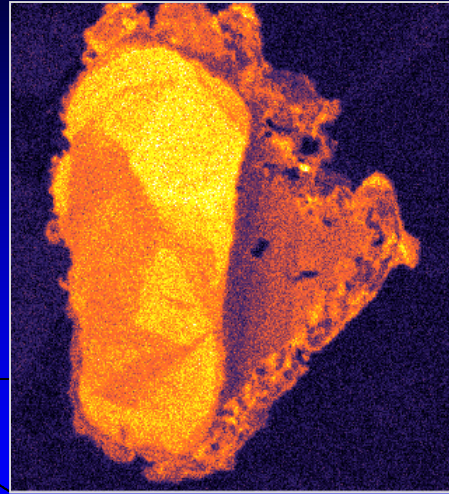




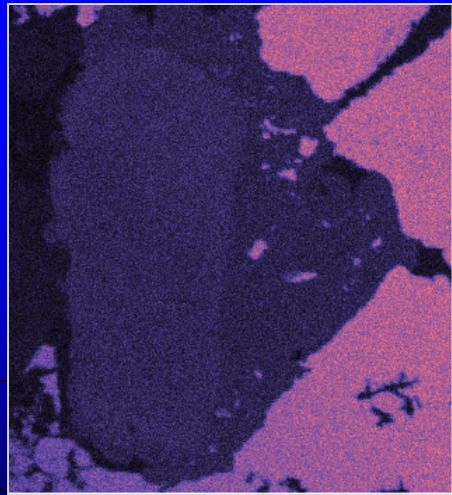




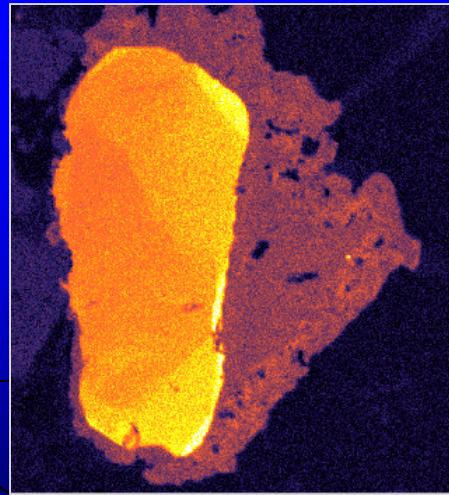
Ca K α



Th M α



U M β



Y L α

—
20 μm

